

Inventory Information

Takayuki

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c/o Tokyo Electron Kyushu Limited,

Process Development Center

650, Mitsuzawa, Hosaka-cho

Nirasaki-shi, Yamanashi-ken

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Citizenship Country:

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Application Information

Title Line One: SUBSTRATE PROCESSING METHOD
Title Line Two: AND SUBSTRATE PROCESSING APPARATUS
Total Drawing Sheets: 10
Formal Drawings?: Yes
Application Type: non-provisional
Docket Number: 199372003500

Representative Information

Representative Customer Number:



25224

PATENT TRADEMARK OFFICE

Continuity Information

This application is a:
> Application One:
Filing Date:

which is a:
>>Application Two:
Filing Date:

which is a:
>>>Application Three:
Filing Date:

199372003500

Prior Foreign Applications

Foreign Application One: 2000-304375
Filing Date: October 4, 2000
Country: Japan
Priority Claimed: Yes

Foreign Application Two: 2001-41482
Filing Date: February 19, 2001
Country: Japan
Priority Claimed: Yes

Assignee Information

Assignee: TOKYO ELECTRON LIMITED

09971136 100301